The Effects of Editing and Imputation on Measured Plant-level and Aggregate Productivity Growth in a Panel of U.S. Manufacturing Plants

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The research presented here was conducted while the first two authors were Special Sworn Status researchers and the third author was an employee of the U.S. Census Bureau. Any opinions and conclusions expressed herein are those of the authors and do not reflect the views of the U.S. Census Bureau. The Census Bureau has reviewed this data product for unauthorized disclosure of confidential information and has approved the disclosure avoidance practices applied to this release (DRB approval number **CBDRB-FY2022-CES020-003**, DMS subproject number **7526913**).



Plant-level Productivity and Data Cleaning

- Large economics literature uses Census Bureau's plant-level manufacturing data to study productivity and productivity dynamics
 - See, e.g., Bailey, Hulten, and Campbell (1992), Olley and Pakes (1992), Bartelsman and Doms (2000), Foster, Haltiwanger, and Syverson (2008), Syverson (2011)
- Literature mostly ignores fact that large % of Census's manufacturing data are <u>imputed</u>
- Data cleaning done by Census Bureau has huge impact on measured cross-sectional productivity dispersion
 - White, Reiter and Petrin (2018), Rotemberg and White (2020)
- How does Census data cleaning affect measured productivity growth?



What We Do in This Paper

- Start with unedited "captured" Annual Survey of Manufactures (ASM), 2009-2013
- Use Census Bureau's edit rules
- Extend Bayesian simultaneous edit-imputation method of Kim, Cox, Kerr, Reiter, and Wang (2015) to panel data
- Compare estimates of aggregate productivity growth using:
 - Data edited-imputed by Census Bureau
 - Data edited-imputed by us using our Bayesian method



The Annual Survey of Manufactures

- Plant-level survey conducted annually*
- Sample size: about 50,000 plants
- Universe is U.S. manufacturing sector (about 300,000 plants)
- Certainty sample:
 - large plants, sampled every year
- Probability sample:
 - Small-to-medium plants, sampled with probability proportional to size
 - 5-year rotating panels beginning in years ending in '4' or '9'



Variables in the ASM

- ASM
 - Collects (at plant-level) and publishes (at industry level) 55 plant-level variables
- This paper:
 - We focus on 5 variables used for measuring productivity:
 - Value of shipments
 - Payroll
 - Employment
 - Cost of materials
 - Capital stock*



Imputation Rates in the ASM









Source: Foster, Grim, Haltiwanger, and Wolf (2017), table A7

ASM Editing and Imputation Comparison

What Census Bureau does

What we do in this paper

Uses within-year ratio edit rules	Same
Uses year-to-year ratio-of-ratios edit rules	Same
Edits-imputes one year at a time (prior-year data is fixed)	Edit-impute 5-year panel simultaneously
Fellegi-Holt editing algorithm (minimizes # of edits)	Simultaneous Bayesian edit-imputation (chooses likeliest variable(s) to edit given the "good" data)
 Uses hierarchy of imputation methods, e.g., Administrative records substitution Uni- or trivariate regression models Analyst corrections 	Use truncated Dirichlet Process mixture of normals to model joint distribution of 5x5 variables
Edit rules & imputation models same within NAICS6	Edit rules & imputation models same within NAICS4
 Administrative records substitution Uni- or trivariate regression models Analyst corrections 	Use truncated Dirichlet Process mixture of normals to model joint distribution of 5x5 variables



Types of ratio edit rules used in the ASM

• Cross-sectional:

$$XLB_{jt} \le \frac{X_{ijt}}{Y_{ijt}} \le XUB_{jt}$$

• Longitudinal :

$$LLB_{j} \leq \frac{\frac{X_{ijt}}{Y_{ijt}}}{\frac{X_{ij,t-1}}{Y_{ij,t-1}}} \leq LUB_{j}$$



Census Editing vs. Bayesian Edit-Imputation (Note: Scatterplots are from Kim et. al (2015) synthetic data)



Census Editing vs. Bayesian Edit-Imputation



Census Editing vs. Bayesian Edit-Imputation



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Census Editing vs. Bayesian Edit-Imputation



Census Bureau Imputation (includes imputation for non-response)





Three Versions of ASM Data

- One "final" dataset edited-imputed by Census
- Two versions of data multiply-edited-and-imputed by us:
 - "El lax" data:
 - use the laxest of the ratio-edit bounds within each NAICS4 industry
 - "El strict" data:
 - use the strictest of the ratio-edit bounds within each NAICS4 industry



Estimates from multiply imputed data

- For each of our models ("lax" and "strict") and within industry:
 - Run an MCMC with a burn-in of 3000 iterations
 - Keep 10 implicates with 300 iterations between implicates
- For each implicate-year, estimate aggregate productivity growth
- Compute means and standard errors across implicates



Aggregate Productivity Growth Rates (annual), 2009-2013 ASM, Census Final vs. El "lax" mean



← final ← EI lax



Aggregate Productivity Growth Rates (annual), 2009-2013 ASM, Census Final vs. El "lax" mean vs. El "strict" mean



← final ← EI lax ← EI strict



Aggregate Productivity Growth Rates (**5-year**), 2009-2013 ASM, Census Final vs. El "lax" mean vs. El "strict" mean





Aggregate Productivity Growth Rates (annual), Census final vs. El "lax" with 95% Confidence Intervals





Aggregate Productivity Growth Rates (annual) Census final vs. El "strict" with 95% Confidence Intervals





Preliminary Conclusions

- The choice of editing and imputation method has a huge effect on measured aggregate productivity growth (APG) in U.S. manufacturing
- Uncertainty of APG estimates due to imputation is also large



Next Steps

- Model validation exercises (training & truth sets)
- Why such big differences between Census final vs. our EI APG measures?
 - Are certain industries driving the results?
 - Small plants with big survey weights and big growth rates?
- Look at the effect of editing and imputation on :
 - Persistence of plant-level productivity (e.g., autocorrelation of TFPR)
 - Variability of plant-level TFP "shocks"
 - Labor productivity growth
 - Association between TFPR and exit
 - All of the above by, e.g., firm size



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